●WEST Search History ●

DATE: Friday, March 29, 2002

Set Name *side by side*	Query	Hit Count	Set Name *result set*
	DB=JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=ADJ		
L24	((clean$3 or etch$3) near2 (gas or vapor)) with (hot near2 (filament or element or wire))	14	L24
	DB=USPT,PGPB; PLUR=YES; OP=ADJ		
L23	((clean$3 or etch$3) near2 (gas or vapor)) with (hot near2 (filament or element or wire))	11	L23
L22	(HF or (hot near2 (filament or element))).ti,ab. and (clean$3 or etch$3).ti,ab. and (chamber or reactor or vessell or vessel).ti,ab.	42	L22
	DB=JPAB,EPAB,DWPI,TDBD; PLUR=YES; OP=ADJ		
L21	(Pt or platinum) and (clean$3 or etch$3) and ((chamber or reactor or vessel or vessell) near3 (wall or interior or surface))	689	L21
L20	(Pt or platinum) and (clean$3 or etch$3) and (chamber or reactor or vessel or vessell)	4266	L20
L19	(Pt or platinum) and (clean$3 or etch$3) and (chamber or reactor or reaction or vessel or vessell)	5557	L19
L18	(Pt or platinum) and ($2CVD or (vapor deposit$3) or clean$3 or etch$3) and (chamber or reactor or reaction or vessel or vessell)	6400	L18
L17	(hot near2 (filament or element)) and (clean$3 or etch$3) and (chamber or reactor or reaction or vessel or vessell)	34	L17
L16	((Pt or platinum) with (filament or ((hot or heat$3) near2 element))) and ($2CVD or (vapor deposit$3) or clean$3 or etch$3)	45	L16
	DB=USPT,PGPB; PLUR=YES; OP=ADJ		
L15	((hot near2 (filament or element)) near15 (clean$3 or etch$3)) and ((427/$).icls. or (134/$).icls. or (216/$)!.icls.)	18	L15
L14	L4 and ((hot near2 (filament or element)) near15 (clean$3 or etch$3))	1	L14
L13	L12 not (L11 or L9)	58	L13
L12	(hot near2 (filament or element)) same (clean$3 or etch$3) same (chamber or reactor or vessel or vessell)	86	L12
L11	L10 not L9	118	L11
L10	(hot near2 (filament or element)) and ($2CVD or (vapor deposit$3)) and ((clean$3 or etch$3) with (chamber or reactor or vessel or vessell))	126	L10
L9	L4 and (filament or ((hot or heat$3) near2 element)) and ($2CVD or (vapor deposit$3)) and ((clean$3 or etch$3) with (chamber or reactor or vessel or vessell))	64	L9
L8	((Pt or platinum) with (filament or ((hot or heat$3) near2 element))) and ((filament or ((hot or heat$3) near2 element)) same ($2CVD or (vapor deposit$3) or clean$3 or etch$3))	197	L8

L7	((Pt or platinum) with (filament or ((hot or heat$3) near2 element))) and ($2CVD or (vapor deposit$3) or clean$3 or etch$3)	436	L7
L6	L4 and ((Pt or platinum) with (filament or ((hot or heat$3) near2 element)))	5	L6
L5	L2 and L3	12	L5
L4	L2 or L3	2721	L4
L3	((216/37).icls. or (216/58).icls. or (216/63).icls. or (134/22.1).icls. or ((134/19)!.ICLS.))	872	L3
L2	((427/230).icls. or (427/235).icls. or (427/237).icls. or (427/248.1).icls. or (427/255.23).icls. or ((427/255.28)!.ICLS.))	1861	L2
L1	(Ishibashi.in.) and ((Pt or platinum) with (filament or ((hot or heat$3) near2 element)))	1	L1

END OF SEARCH HISTORY